SFI Sputter #2 Operating Instructions

1. Loosen thumbscrew a few turns on cassette module.
2. Vent cassette module by selecting “Vent CM” from menu.
3. Load Dedicated cassette with 4” wafers, device side down and major flat towards slot valve.
4. Close CM door and tighten CM door thumbscrew. (Do not over tighten)
5. From the menu select “Start Process”
6. Enter Lot ID, select sequence, slot range and data log interval.
7. Select OK.
8. When process is complete, loosen CM thumbscrew, select “Vent CM”.
9. Remove wafers.
10. Close CM door and tighten CM door thumbscrew. (Do not over tighten)
11. Select “Pump CM”.
12. Fill out logbook.
13. Complete.